



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

February 12, 2026	
IGI Report Number	LG771644950
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE EMERALD CUT
Measurements	6.31 X 6.27 X 4.13 MM

GRADING RESULTS

Carat Weight	1.60 CARAT
Color Grade	E
Clarity Grade	VS2

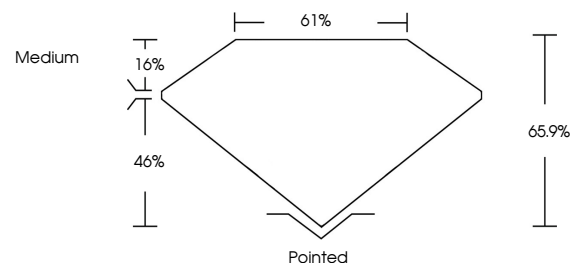
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG771644950

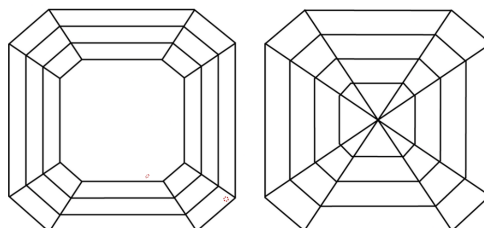
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG771644950
Report verification at lgi.org

PROPORTIONS

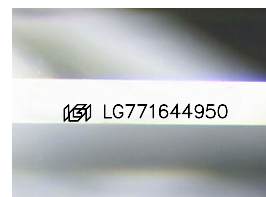


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

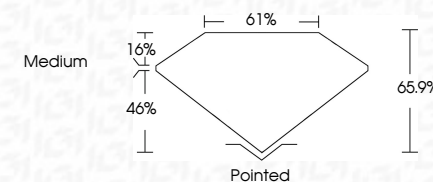
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Clarity Grade	VVS 2



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February 12, 2026	1.40 CARAT
GI Report No. [G77] 1644950	VVS 2
SQUARE EMERALD CUT	65.9%
	0.1%
	Medium
	Polished
	EXCELLENT
	EXCELLENT
	NONE
	ser [G77] 1644950

Comments:
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www.igi.org